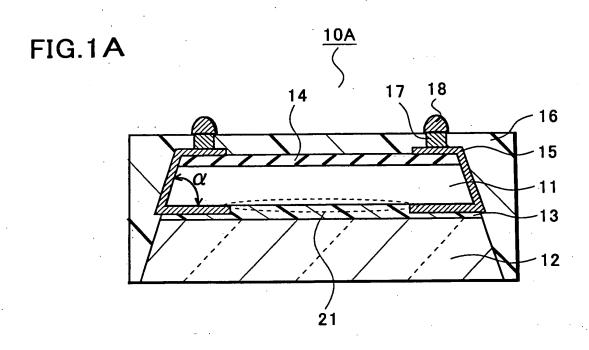


Marin No.: 14225-046001
Appeant(s): Koujiro Kameyama et al.
SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURE THEREOF



BEST AVAILABLE (



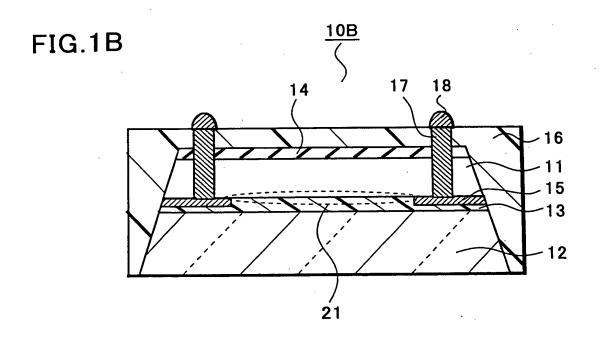




FIG.2A

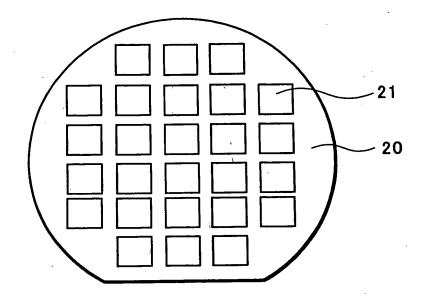


FIG.2B

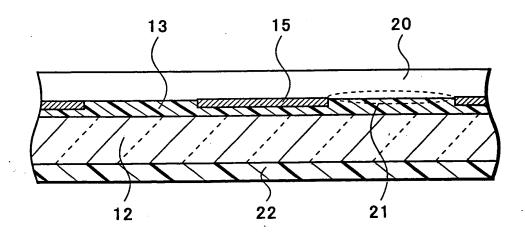


FIG.3A

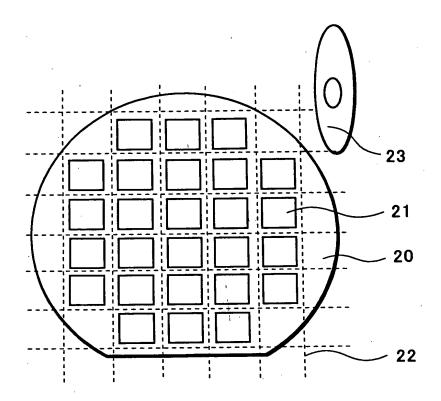


FIG.3B

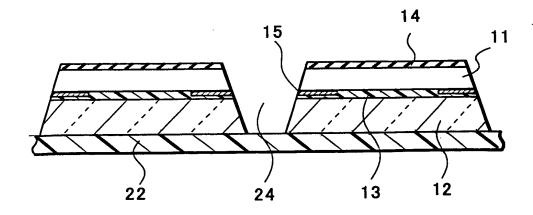


FIG.4A

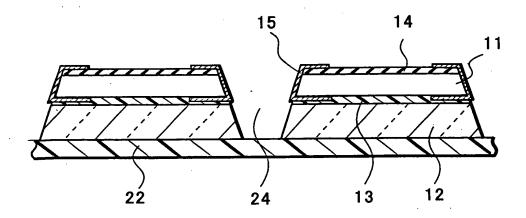


FIG.4B

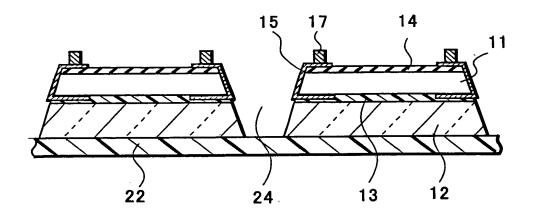


FIG.5A

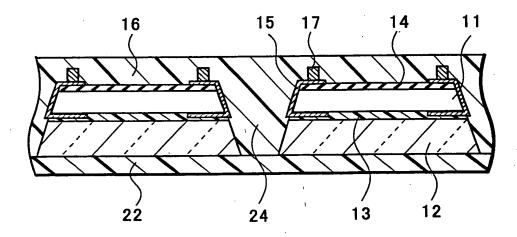


FIG.5B

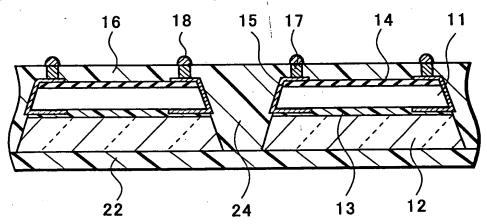
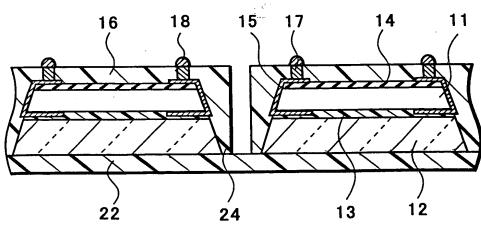


FIG.5C





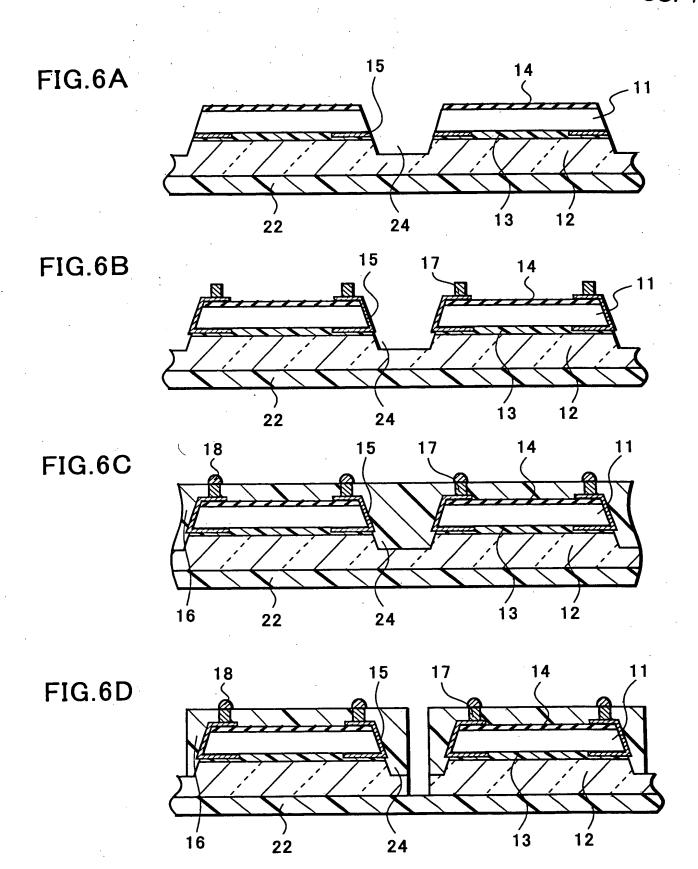


FIG.7

